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Application Number	10083533
Filing Date	2002-02-27
First Named Inventor	Hiroshi HASHIMOTO
Art Unit	2814
Examiner Name	Wai Sing Louie
Attorney Docket Number	020244

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1	International Business Machines, "A single-layer polysilicon EEPROM memory cell using diffusion gate"; January 1, 1999, Research Disclosure, Mason Publications, Hampshire, GB, XP007123866; ISSN: 0374-4353.	<input type="checkbox"/>
2	European Search Report; European Patent Application No. EP 08105801.8-1235, dated December 22, 2008	<input type="checkbox"/>

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